AF / JDFW

PATENT
03345-P0042A WWW/DWA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Johannes Kaeppeler, *et al.*
Application No. 10/685,233	Filing Date: October 14, 2003
Title of Application:	Method For Depositing Especially Crystalline Layers From The Gas Phase Onto Especially Crystalline Substrates
Confirmation No. 4633	Art Unit: 1722
Examiner	Robert M. Kunemund

Mail Stop AF
Commissioner for Patents
Post Office Box 1450
Alexandria, VA 22313-1450

Response to Final Official Action

In response to the Official Action of July 26, 2005, Applicant submits the following Remarks. Applicant believes that the entry of this Response is proper as it makes no amendments to the claims. Applicant believes that no fee is due in connection with the filing of this Response. However, if any fee is due, please charge Deposit Account No. 19-4516.

Mailing Certificate: I hereby certify that this correspondence is today being deposited with the U.S. Postal Service as *First Class Mail* in an envelope addressed to: Commissioner for Patents and Trademarks; Post Office Box 1450; Alexandria, VA 22313-1450.

September 23, 2005

Paul Bosler